



IFW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro SAKURADA et al.

Group Art Unit: 2818

Application No.: 10/500,580

Examiner: C. LEE

Filed: July 1, 2004

Docket No.: 120222

For: AN SOI WAFER AND A METHOD FOR PRODUCING AN SOI WAFER

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the November 14, 2005, Office Action, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**